

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)
Hirozoh TSURUTA et al.	) Group Art Unit:
Application No.: Unassigned	) Examiner:
Filed: June 23, 2005	) Confirmation No.:
For: SLURRY FOR CUTTING SILICON	)
INGOT AND METHOD OF CUTTING	)
SILICON INGOT USING THE SAME	)

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-captioned application, it is requested that  
this application be amended as set forth herein.